

Model FS6022

MEMS Mass Flow Sensors

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Model FS6022

Features

- Mass flow range: 0 ~ 250 SLPM, 0 ~ 300 SLPM
- Fast response time: 8 ms typical
- Highly sensitive in small flow rate
- Low power consumption
- Specially designed for medical equipment
- Sterilizable for reuse



Description

The FS6022 mass flow sensors are manufactured using Siargo's proprietary MEMS flow sensor and package technology. The sensors are specially designed for the application of medical equipment such as personal ventilators and CPAP machines for flow monitoring and control with two flow rate ranges of 0 ~ 250 SLPM and 0 ~ 300 SLPM, respectively. The compact package design enables a large dynamic flow range with a flow resistance less than $<0.5 \text{ cmH}_2\text{O/L/sec}$. This package withstands a maximum pressure of 0.2 MPa (29 psi) without compromising performance. The mechanical interface is the standard ISO 22 mm combined male/female medical connector that allows the sensor to be readily applied to equipment with a minimal possible dead space.

The FS6022 requires a power supply of 5 Vdc. FS6022A provides a linearized analog output of 0 to 5 Vdc corresponding with flow rate from 0 to full scale. While FS6022B provides an analog output of 2.5 ~ 5

Vdc corresponding with 0 ~ positive full scale flow rate, and 2.5 ~ 0 Vdc corresponding with 0 ~ negative full scale flow rate. It can also provide a digital interface through RS232 (TTL) upon requests. The AMP compatible mechanical connector provides reliable connection.

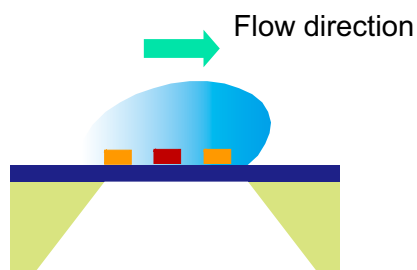
The response time of the FS6022 is 8 ms typically, which allows customers to monitor instant flow rate variations.

The calibration is generally performed with air at 20 °C and 101.325 kPa pressure rating. It can nonetheless be carried out with other gases and conditions upon requests.

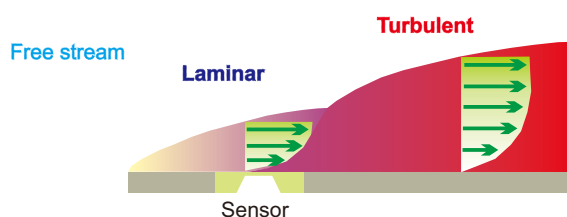
The sensors can be sterilized in medical liquids for reuse or hygienic purposes. The sensors can also be applied for various clean gas measurement with low cost and easy installation. They can be used as a good alternative to volumetric and/or differential pressure type flow sensors.

Working Principle

The MEMS sensor chip utilizes the calorimetric principle. It is packaged on a plate installed inside the flow channel, which provides additional flow conditioning from the boundary layer configuration resulting in a laminar flow. The mass flow measurement is established as the gas carries heat away from the heater leading to the redistribution of the temperature field. Accurate flow rate is obtained by calibration with standard gas at preset conditions.



Time-averaged velocity profile boundary layer

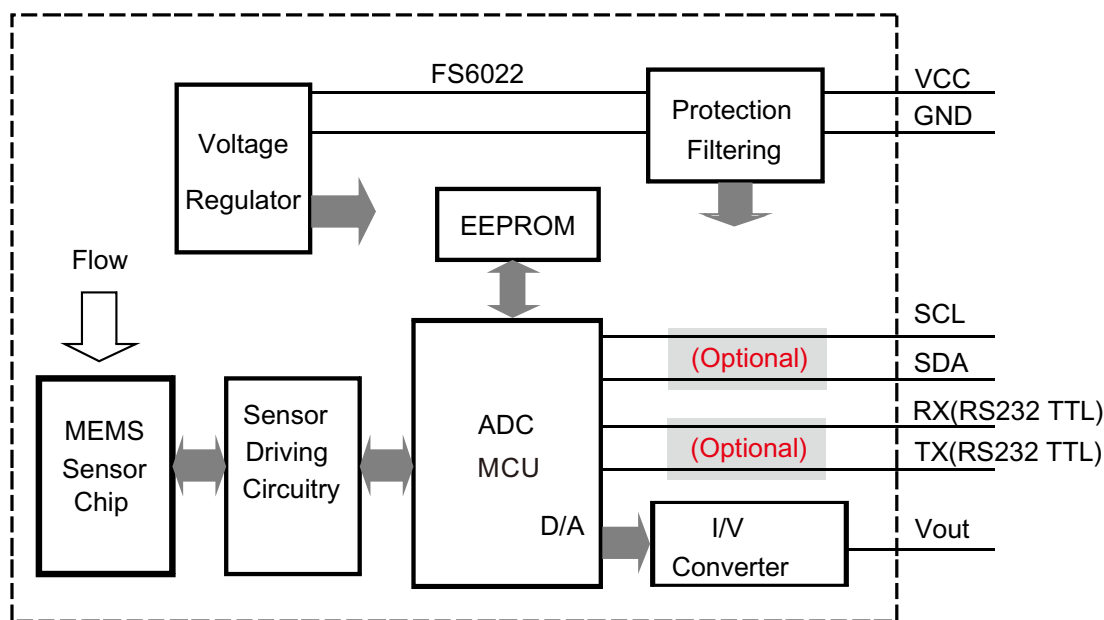


MEMS Mass Flow Sensors

Block Diagram

The functional block diagram is shown in the following figure. The critical component of the FS6022 is the MEMS sensor chip that is heavily framed in the figure. It is powered by the sensor driving circuitry and sends

flow rate related voltage to ADC. The micro-controller processes (amplifies, filters, etc) the voltage then converts into flow rate. The flow rate signal is sent out through analog format.



Functional block diagram of the FS6022.

MEMS Mass Flow Sensors

1. Sensor Performance

1.1 Performance Specifications

All data unless otherwise noted apply for calibration conditions: air, 20 °C, 101.325 kPa absolute pressure, horizontal mounting.

Model	FS6022A	FS6022B	
Flow Range	0 ~ 250; 0 ~ 300	0 ~ ±250; 0 ~ ±300	SLPM
Turn-down Ratio	> 100 : 1		
Accuracy ¹	± (2 + 0.5FS)		
Repeatability	± 0.5		
Null Shift	± 30		
Output Shift	± 0.12		
Response Time	8		
Output ²	Linear Analog 0 ~ 5 Vdc RS232(TTL) / I ² C	Linear Analog 2.5 ~ 0 / 2.5 ~ 5 Vdc RS232(TTL) / I ² C	
Max. Flow Resistance ³	<0.5 cmH ₂ O/L/sec		
Max. Operation Pressure	0.2		
Power Supply ⁴	5 ± 1%		
Operating Current	< 10 (no output load)		
Power Consumption	< 50		
Analog Output Load	Sourcing: 14		
	Sinking: 11		
Working Temperature ⁵	0 ~ +60		

1. To obtain accurate flow measurement, let the sensor warm up 1 minute at power up.

2. For FS6022A, the analog output provides linearized voltage of 0 ~ 5 Vdc corresponding with flow rate of 0 ~ full scale. For FS6022B, the analog output provides linearized voltage of 2.5 ~ 5 Vdc corresponding with flow rate of 0 ~ positive full scale, and 2.5 ~ 0 Vdc corresponding with flow rate of 0 ~ negative full scale

3. At 20°C and 50 kPag pressure rating.

4. One 5 Vdc power supply with an accuracy of ±1% is necessary. The minimum supply current must be larger than 10mA.

1.2 Additional Specifications

Mechanical Connection	ISO 22 mm		
Pins Out ¹	Connector:5 Pins, NS-TECH CD R-5; Cable:SN5-50,0.5 m		
Calibration Options ²	Air @ 20 °C, 101.325 kPa		
Dimension	65.3 x 30 x 38.5		
Weight	30.0		
Storage Temperature	-25 ~ +85		
Humidity	< 95 %RH (No icing or condensation)		

1 The cable (Part number: SN5-50, Length: 0.5 m) is shipped with the sensor.

2 The sensor is normally calibrated with air at 20 °C and 101.325 kPa pressure rating. Calibrations at other gases and conditions available upon request.

MEMS Mass Flow Sensors

1.3 Flow Characteristics

The FS6022A provides an analog output of 0 ~ 5 Vdc corresponding with 0 ~ full scale flow rate. While the FS6022B provides an analog output of 2.5 ~ 5 Vdc corresponding with 0 ~ positive full scale flow rate, and 2.5 ~ 0 Vdc corresponding with 0 ~ negative full scale

flow rate. Using full scale 250 SLPM and ± 300 SLPM as examples, the typical analog output v.s. flow rate is illustrated in Table 1.1, Table 1.2 and Figure 1.1, Figure 1.2. The data is obtained at 5.0 Vdc supply.

Table 1.1: Typical output voltage v.s. flow rate.

Flow Rate (SLPM)	Typical Voltage (Vdc)
0	0
25	0.5
50	1.0
100	2.0
150	3.0
200	4.0
250	5.0

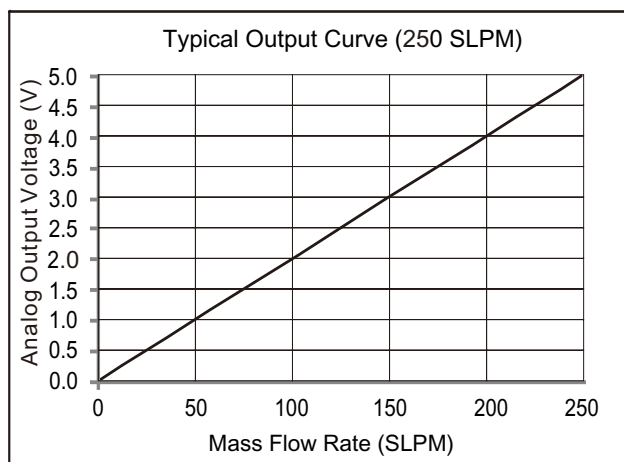


Figure 1.1: The typical analog output curve of FS6022A with the full scale of 250 SLPM.

Table 1.2: Typical output voltage v.s. flow rate.

Flow Rate (SLPM)	Typical Voltage (Vdc)	Flow Rate (SLPM)	Typical Voltage (Vdc)
-300	0	+50	2.92
-250	0.42	+100	3.33
-200	0.83	+150	3.75
-150	1.25	+200	4.17
-100	1.67	+250	4.58
-50	2.08	+300	5.0
0	2.5		

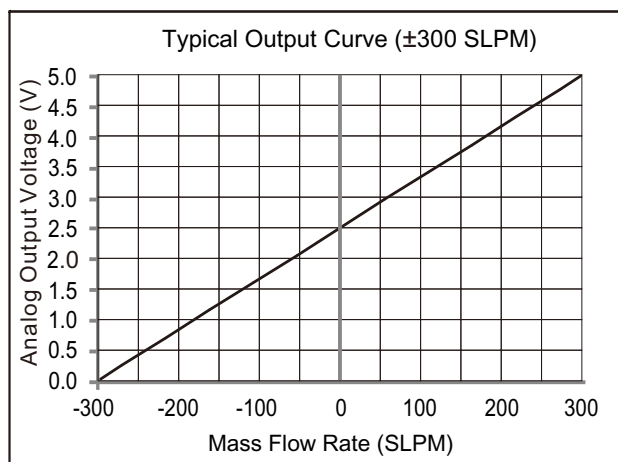


Figure 1.2: The typical analog output curve of FS6022B with the full scale of ± 300 SLPM.

1.4 Pressure Drop Characteristics

The FS6022 is packaged with a low pressure drop design. The pressure drop is measured throughout the entire measurement range. The results are shown in Table 1.3 and Figure 1.3.

Table 1.3: FS6022 pressure drop v.s. flow rate.

Flow Rate (SLPM)	0	50	100	150	200	250
Pressure Drop (Pa)	0	30	90	180	300	450

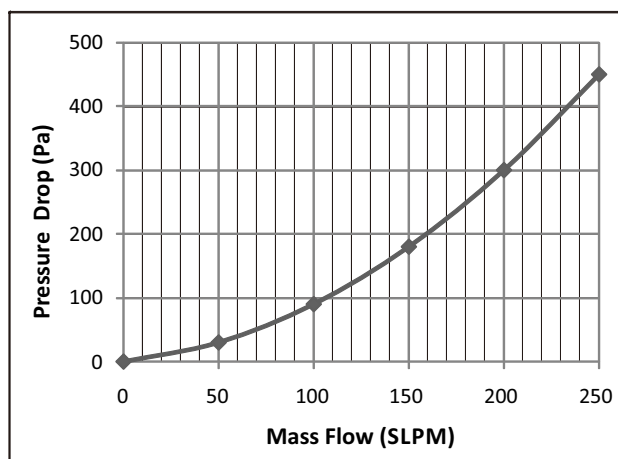


Figure 1.3: FS6022 pressure drop v.s. flow rate.

MEMS Mass Flow Sensors

2. Electrical Interface

2.1 Pin Definition

The FS6022 provides a 5-pin interface. The output connecting cable comes with the sensor. The sensor pin layout is shown in Figure 2.1 and the cable color code is defined in Table 2.1.

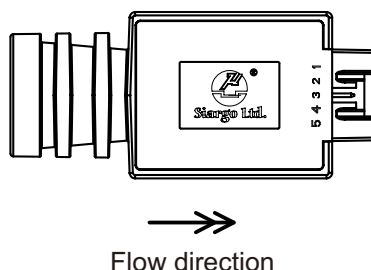


Figure 2.1: FS6022 pin layout.

Table 2.1: FS6022 cable color code.

Pin #	Color	Definition
1	Blue	TX (RS232 TTL) / SDA (I ² C)
2	Green	Vout, Analog output
3	Red	VCC, Power supply
4	Black	GND, Ground
5	Yellow	RX (RS232 TTL) / SLK (I ² C)

2.2 Pin Description

VCC and GND: The FS6022 requires a power supply of $5 \pm 1\%$ Vdc. The voltage is internally filtered and regulated to power the circuit. The accuracy of the power supply will influence the sensor output and the $\pm 1\%$ accuracy requirement should be met to the specified performance. The sensor consumes less than 10 mA normally and the minimum supply current must be larger than 10 mA.

Vout: The analog output pin provides 0 ~ 5 Vdc corresponding with the specified flow range 0 ~ full scale.

TX and RX: The RS232 communication is bidirectional. TX is the transmit pin for RS232 and it sends out signal from the sensor. RX is the receive pin and it receives signal. Using these two pins together with GND pin, the sensor's operation mode and response time can be configured, and the voltage as well as flow rate can be obtained.

If I²C communication is preferred, then these two pins are for **SDA** and **SCL** respectively. Please contact Siargo for protocol.

3. Mechanical Dimensions and Mountings

3.1 Mechanical Interface

The FS6022 provides standard ISO-22mm medical connection and can be readily applied to personal ventilators and/or CPAP machines. The inlet is a male interface and the outlet is a female one. See Figure 3.1 for details.

3.2 Mechanical Dimensions

The sensor has a total size of 65.3 X 30 X 38.5 mm, as shown in Figure 3.1.

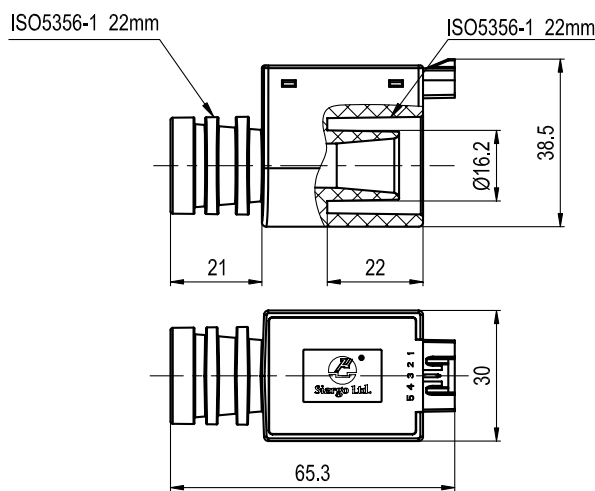


Figure 3.1: The FS6022 mechanical dimensions.

MEMS Mass Flow Sensors

4. Cleaning and Sterilization

The FS6022 can be sterilized for reuse. The sterilization can be performed with liquid, gas and ultra violet. For autoclave, please contact manufacturer. The liquid sterilization is described as the following.

- Immerse the FLOW CHANNEL of the sensor into the sterilizing solution. Make sure the entire sensor body is within the solution but not the electronic cover, stay in for 30 min.

- Then rinse the sensor by immersing it under DI water for 30 min. Change with clean DI water for another 30 min.

- Dry the sensor in oven at 65 °C for 120 min.

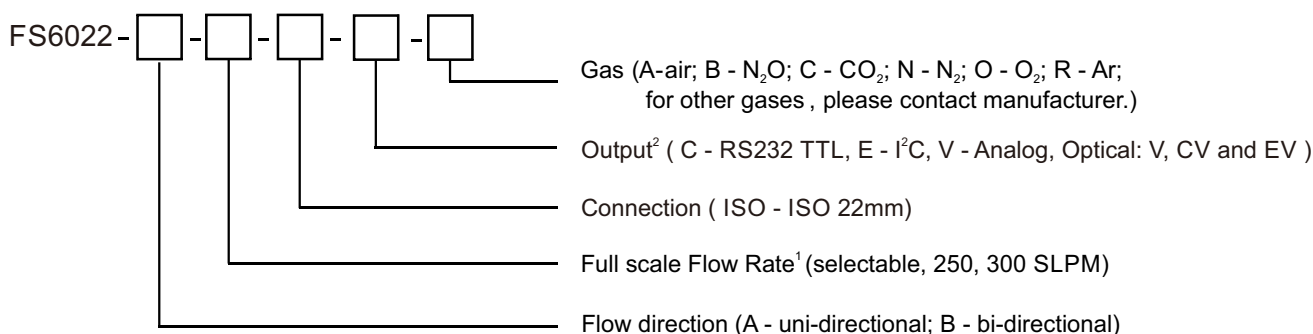
If sterilize with gas or ultra-violet, simply put the sensor in the sterilizing environment for 30 min.

Notice: During sterilization, the sensor must be powered off.

5. Ordering Guide

5.1 Sensor Selection

The sensor part number is composed of the product model number and suffix indicating the full scale flow rate, mechanical connection, output format as well as the application gas. Refer the following for details.



¹ Max. flow rate number only, for example, 250 meaning full scale flow rate of 250SLPM. Other full scale flow rate can be customized.

² The sensor shipped with standard analog output. RS232(TTL) and I²C are optional.

5.2 Order Contact and Customer Support

The sales offices are listed at the end of this document. For small quantities, the order can be placed either through Siargo website: www.siargo.com or the convenient sales office. For large quantities, please contact the sales office, distributors or sales representatives.

Siargo is making every effort to ensure the quality of the products. In case of questions and/or product supports, please contact customer service listed at the end of the document.

Important Notices

Wetted Materials and Compatibility

The sensor body is made of medical compatible plastics. The sensor chip comprises of silicon, silicon nitride and silicon dioxide and the sensor chip surfaces are passivated with silicon nitride and silicon dioxide. The electronic sealing is provided by RTV (room temperature vulcanizing) silicone sealant WR-704 composed of HOCH₃(SiO)_nCH₃H.

Compliance Statement

All components of this product are RoHS compliant. The product fully complies with CE norm EN61000-6-1 through 61000-6-4, EN50081-2 through 50082-2 and EMC directive 89/336/EEC.

Cautions for Handling and Installations

The product at the time of shipment is fully inspected for product quality and meets all safety requirements. Additional safety measures during handling and installation should be applied. To prevent ESD (electrostatic discharge) damage and /or degradation, take customary and statutory ESD precautions when handling. Do power the product with the correct polarity, voltage & amperage. All precautions and measures for electrical voltage handling must apply. The product sealing is ensured to work under working pressure of 0.2MPa and is leakage proof before the shipment. But cautions and further leakage test are important at installation as well since any leakage could cause severe safety issue.

MEMS Mass Flow Sensors

This product contains no user serviceable components. Do not attempt to disassemble, substitute parts or perform unauthorized modifications to the product. Doing so will forfeit the terms of the warranty and cause the liability to any damages thereafter. It should only be serviced by authorized personnel. Upon requests, Siargo will provide necessary technical support and/or training of the personnel.

Cautions for Product Applications

The product is designed for use with general purpose gases such as air and nitrogen. It is advised that the products are best used for non-explosive clean gases. The sensors cannot be used for gas metrology of fluoride or fluoride-containing gases. For updates of the product certification information, please contact the manufacturer. Use for other gases such as extreme corrosive and toxic may cause the product malfunctioning or even severe damages.

Don't expose the product's electronics other than the inner flow channel to any liquids, the unit does not have a water proof electronics. For medical sterilization procedure, please use the reference stated in this manual. Don't flow gas in conditions that can cause condensing water vapor to be trapped inside the unit during operation as the accuracy could be significantly influenced.

It is suggested to design your application so that nominal flow rate is approximately 70% of the full scale flow rating of the sensor. Don't use a sensor with a flow range at the extreme cases, for instance, don't use a 250 SLPM sensor for a 2.5 SLPM application.

Warranty and Liability

(Effective January 2010)

Siargo warrants the products sold hereunder, properly used and properly installed under normal circumstances and service as described in this user

manual, shall be free from faulty materials or workmanship for 180 days for OEM products, and 365 days for non-OEM products from the date of shipment. This warranty period is inclusive of any statutory warranty. Any repair or replacement serviced product shall bear the same terms in this warranty.

Siargo makes no other warranty, express or implied and assumes no liability for any special or incidental damage or charges, including but not limited to any damages or charges due to installation, dismantling, reinstallation or any other consequential or indirect damages of any kind. To the extent permitted by law, the exclusive remedy of the user or purchaser, and the limit of Siargo's liability for any and all losses, injuries or damages concerning the products including claims based on contract, negligence, tort, strictly liability or otherwise shall be the return of products to Siargo, and upon verification of Siargo to prove to be defective, at its sole option, to refund, repair or replacement of the products. No action, regardless of form, may be brought against Siargo more than 365 days after a cause of action has accrued. The products returned under warranty to Siargo shall be at user or purchaser's risk of loss, and will be returned, if at all, at Siargo's risk of loss. Purchasers or users are deemed to have accepted this limitation of warranty and liability, which contains the complete and exclusive limited warranty of Siargo, and it shall not be amended, modified or its terms waived except by Siargo's sole action.

This warranty is subject to the following exclusions:

- (1) Products that have been altered, modified or have been subject to unusual physical or electrical circumstances indicated but not limited to those stated in this document or any other actions which cannot be deemed as proper use of the products;
- (2) Siargo does not provide any warranty on finished goods manufactured by others. Only the original manufacturer's warranty applies;
- (3) Products re-sold to the third parties.